IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KANNO, et al.

Serial No.: 10/591,474 Filed: September 1, 2006

For: Two-Fluid Nozzle for Cleaning Substrate
AND Substrate Cleaning Apparatus

Confirmation No. 1445

Art Unit: 1711

Examiner: Benjamin Lee Osterhout

Attorney Docket: 033082M341

RESPONSE UNDER 37 C.F.R. 1.114

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Mail Stop: RCE

Dear Sir:

This is in response to the Office Action mailed January 5, 2011, to which the time for response was set to expire April 5, 2011. A Petition for an Extension of Time and the requisite fee are submitted herewith to extend the due date for response to May 5, 2011. The pending claims, claims 1, 2 and 5–13, were rejected. Reconsideration and entry of the following amendments are respectfully requested.

Amendment to the Claims begins on page 2 of this paper. Remarks begin on page 5 of this paper.